

- Preface p. v
- 1. Introduction p. 1
- 1.1. Introduction p. 1
- 1.2. Emergence of Nanotechnology p. 4
- 1.3. Bottom-Up and Top-Down Approaches p. 7
- 1.4. Challenges in Nanotechnology p. 10
- 1.5. Scope of the Book p. 11
- References p. 14
- 2. Physical Chemistry of Solid Surfaces p. 15
- 2.1. Introduction p. 15
- 2.2. Surface Energy p. 17
- 2.3. Chemical Potential as a Function of Surface Curvature p. 26
- 2.4. Electrostatic Stabilization p. 32
- 2.4.1. Surface charge density p. 32
- 2.4.2. Electric potential at the proximity of solid surface p. 33
- 2.4.3. Van der Waals attraction potential p. 36
- 2.4.4. Interactions between two particles: DLVO theory p. 38
- 2.5. Steric Stabilization p. 42
- 2.5.1. Solvent and polymer p. 43
- 2.5.2. Interactions between polymer layers p. 45
- 2.5.3. Mixed steric and electric interactions p. 47
- 2.6. Summary p. 48
- References p. 48
- 3. Zero-Dimensional Nanostructures: Nanoparticles p. 51
- 3.1. Introduction p. 51
- 3.2. Nanoparticles through Homogeneous Nucleation p. 53
- 3.2.1. Fundamentals of homogeneous nucleation p. 53
- 3.2.2. Subsequent growth of nuclei p. 58
- 3.2.2.1. Growth controlled by diffusion p. 59
- 3.2.2.2. Growth controlled by surface process p. 59
- 3.2.3. Synthesis of metallic nanoparticles p. 63
- 3.2.3.1. Influences of reduction reagents p. 67
- 3.2.3.2. Influences by other factors p. 69
- 3.2.3.3. Influences of polymer stabilizer p. 72
- 3.2.4. Synthesis of semiconductor nanoparticles p. 74
- 3.2.5. Synthesis of oxide nanoparticles p. 81
- 3.2.5.1. Introduction to sol-gel processing p. 82
- 3.2.5.2. Forced hydrolysis p. 85
- 3.2.5.3. Controlled release of ions p. 87
- 3.2.6. Vapor phase reactions p. 88
- 3.2.7. Solid state phase segregation p. 89
- 3.3. Nanoparticles through Heterogeneous Nucleation p. 93
- 3.3.1. Fundamentals of heterogeneous nucleation p. 93
- 3.3.2. Synthesis of nanoparticles p. 95
- 3.4. Kinetically Confined Synthesis of Nanoparticles p. 96
- 3.4.1. Synthesis inside micelles or using microemulsions p. 96

- 3.4.2. Aerosol synthesis p. 98
- 3.4.3. Growth termination p. 99
- 3.4.4. Spray pyrolysis p. 100
- 3.4.5. Template-based synthesis p. 101
- 3.5. Epitaxial Core-Shell Nanoparticles p. 101
- 3.6. Summary p. 104
- References p. 105
- 4. One-Dimensional Nanostructures: Nanowires and Nanorods p. 110
- 4.1. Introduction p. 110
- 4.2. Spontaneous Growth p. 111
- 4.2.1. Evaporation (dissolution)-condensation growth p. 112
- 4.2.1.1. Fundamentals of evaporation (dissolution)-condensation growth p. 112
- 4.2.1.2. Evaporation-condensation growth p. 119
- 4.2.1.3. Dissolution-condensation growth p. 123
- 4.2.2. Vapor (or solution)-liquid-solid (VLS or SLS) growth p. 127
- 4.2.2.1. Fundamental aspects of VLS and SLS growth p. 127
- 4.2.2.2. VLS growth of various nanowires p. 131
- 4.2.2.3. Control of the size of nanowires p. 134
- 4.2.2.4. Precursors and catalysts p. 138
- 4.2.2.5. SLS growth p. 140
- 4.2.3. Stress-induced recrystallization p. 142
- 4.3. Template-Based Synthesis p. 143
- 4.3.1. Electrochemical deposition p. 144
- 4.3.2. Electrophoretic deposition p. 151
- 4.3.3. Template filling p. 157
- 4.3.3.1. Colloidal dispersion filling p. 158
- 4.3.3.2. Melt and solution filling p. 160
- 4.3.3.3. Chemical vapor deposition p. 161
- 4.3.3.4. Deposition by centrifugation p. 161
- 4.3.4. Converting through chemical reactions p. 162
- 4.4. Electrospinning p. 164
- 4.5. Lithography p. 165
- 4.6. Summary p. 168
- References p. 168
- 5. Two-Dimensional Nanostructures: Thin Films p. 173
- 5.1. Introduction p. 173
- 5.2. Fundamentals of Film Growth p. 174
- 5.3. Vacuum Science p. 178
- 5.4. Physical Vapor Deposition (PVD) p. 182
- 5.4.1. Evaporation p. 183
- 5.4.2. Molecular beam epitaxy (MBE) p. 185
- 5.4.3. Sputtering p. 186
- 5.4.4. Comparison of evaporation and sputtering p. 188
- 5.5.3. Transport phenomena p. 191
- 5.5. Chemical Vapor Deposition (CVD) p. 189
- 5.5.1. Typical chemical reactions p. 189

- 5.5.2. Reaction kinetics p. 190
- 5.5.4. CVD methods p. 194
- 5.5.5. Diamond films by CVD p. 197
- 5.6. Atomic Layer Deposition (ALD) p. 199
- 5.7. Superlattices p. 204
- 5.8. Self-Assembly p. 205
- 5.8.1. Monolayers of organosilicon or alkylsilane derivatives p. 208
- 5.8.2. Monolayers of alkanethiols and sulfides p. 210
- 5.8.3. Monolayers of carboxylic acids, amines and alcohols p. 212
- 5.9. Langmuir-Blodgett Films p. 213
- 5.10. Electrochemical Deposition p. 218
- 5.11. Sol-Gel Films p. 219
- 5.12. Summary p. 223
- References p. 224
- 6. Special Nanomaterials p. 229
- 6.1. Introduction p. 229
- 6.2. Carbon Fullerenes and Nanotubes p. 230
- 6.2.1. Carbon fullerenes p. 230
- 6.2.2. Fullerene-derived crystals p. 232
- 6.2.3. Carbon nanotubes p. 232
- 6.3. Micro and Mesoporous Materials p. 238
- 6.3.1. Ordered mesoporous structures p. 239
- 6.3.2. Random mesoporous structures p. 245
- 6.3.3. Crystalline microporous materials: zeolites p. 249
- 6.4. Core-Shell Structures p. 257
- 6.4.1. Metal-oxide structures p. 257
- 6.4.2. Metal-polymer structures p. 260
- 6.4.3. Oxide-polymer structures p. 261
- 6.6. Intercalation Compounds p. 266
- 6.5. Organic-Inorganic Hybrids p. 263
- 6.5.1. Class I hybrids p. 263
- 6.5.2. Class II hybrids p. 264
- 6.7. Nanocomposites and Nanograined Materials p. 267
- 6.8. Summary p. 268
- References p. 269
- 7. Nanostructures Fabricated by Physical Techniques p. 277
- 7.1. Introduction p. 277
- 7.2. Lithography p. 278
- 7.2.1. Photolithography p. 279
- 7.2.2. Phase-shifting photolithography p. 283
- 7.2.3. Electron beam lithography p. 284
- 7.2.4. X-ray lithography p. 287
- 7.2.5. Focused ion beam (FIB) lithography p. 288
- 7.2.6. Neutral atomic beam lithography p. 290
- 7.3. Nanomanipulation and Nanolithography p. 291
- 7.3.4. Nanomanipulation p. 298

- 7.3.1. Scanning tunneling microscopy (STM) p. 292
- 7.3.2. Atomic force microscopy (AFM) p. 294
- 7.3.3. Near-field scanning optical microscopy (NSOM) p. 296
- 7.3.5. Nanolithography p. 303
- 7.4. Soft Lithography p. 308
- 7.4.1. Microcontact printing p. 308
- 7.4.2. Molding p. 310
- 7.4.3. Nanoimprint p. 310
- 7.4.4. Dip-pen nanolithography p. 313
- 7.5. Assembly of Nanoparticles and Nanowires p. 314
- 7.5.1. Capillary forces p. 315
- 7.5.2. Dispersion interactions p. 316
- 7.5.3. Shear force assisted assembly p. 318
- 7.5.4. Electric-field assisted assembly p. 318
- 7.5.5. Covalently linked assembly p. 319
- 7.5.6. Gravitational field assisted assembly p. 319
- 7.5.7. Template-assisted assembly p. 319
- 7.6. Other Methods for Microfabrication p. 321
- 7.7. Summary p. 321
- References p. 322
- 8. Characterization and Properties of Nanomaterials p. 329
- 8.1. Introduction p. 329
- 8.2. Structural Characterization p. 330
- 8.2.1. X-ray diffraction (XRD) p. 331
- 8.2.2. Small angle X-ray scattering (SAXS) p. 333
- 8.2.3. Scanning electron microscopy (SEM) p. 336
- 8.2.4. Transmission electron microscopy (TEM) p. 338
- 8.2.5. Scanning probe microscopy (SPM) p. 340
- 8.2.6. Gas adsorption p. 343
- 8.3. Chemical Characterization p. 344
- 8.3.1. Optical spectroscopy p. 345
- 8.3.2. Electron spectroscopy p. 349
- 8.3.3. Ionic spectrometry p. 350
- 8.4. Physical Properties of Nanomaterials p. 352
- 8.4.1. Melting points and lattice constants p. 353
- 8.4.2. Mechanical properties p. 357
- 8.4.3. Optical properties p. 362
- 8.4.3.1. Surface plasmon resonance p. 362
- 8.4.3.2. Quantum size effects p. 367
- 8.4.4. Electrical conductivity p. 371
- 8.4.4.1. Surface scattering p. 371
- 8.4.4.2. Change of electronic structure p. 374
- 8.4.4.3. Quantum transport p. 375
- 8.4.4.4. Effect of microstructure p. 379
- 8.4.5. Ferroelectrics and dielectrics p. 380
- 8.4.6. Superparamagnetism p. 382

- 8.5. Summary p. 384
- References p. 384
- 9. Applications of Nanomaterials p. 391
- 9.1. Introduction p. 391
- 9.2. Molecular Electronics and Nanoelectronics p. 392
- 9.3. Nanobots p. 394
- 9.4. Biological Applications of Nanoparticles p. 396
- 9.5. Catalysis by Gold Nanoparticles p. 397
- 9.6. Band Gap Engineered Quantum Devices p. 399
- 9.6.1. Quantum well devices p. 399
- 9.6.2. Quantum dot devices p. 401
- 9.7. Nanomechanics p. 402
- 9.8. Carbon Nanotube Emitters p. 404
- 9.9. Photoelectrochemical Cells p. 406
- 9.10. Photonic Crystals and Plasmon Waveguides p. 409
- 9.10.1. Photonic crystals p. 409
- 9.10.2. Plasmon waveguides p. 411
- 9.11. Summary p. 411
- References p. 412
- Appendix
- 1. Periodic Table of the Elements p. 419
- 2. The International System of Units p. 420
- 3. List of Fundamental Physical Constants p. 421
- 4. The 14 Three-Dimensional Lattice Types p. 422
- 5. The Electromagnetic Spectrum p. 423
- 6. The Greek Alphabet p. 424
- Index p. 425